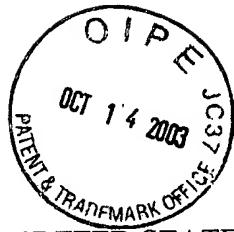


00862.022173



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,906

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
METHOD OF MANUFACTURING THE
SAME, CHARGED-PARTICLE BEAM
EXPOSURE APPARATUS, AND DEVICE
MANUFACTURING METHOD

)
: Examiner: K.T. Nguyen
)
: Group Art Unit: 2881
)
: Confirmation No.: 5368
)
: Allowed: July 11, 2003
)
: October 14, 2003
)
: (Tuesday After Holiday)
)

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application

as follows:

10/17/2003 MAHMED1 00000042 09819906

02 FC:1201
03 FC:1202

172.00 0P
90.00 0P